

LIST	OF	PU	JBLICATIONS
CITI	ED F	3Y	APPLICANT .

Atty Docket No. 0553-0387	<u>Serial No.</u> 10/733,103
<u>Applicant</u> Takeshi OSADA	
<u>Filing Date</u> December 11, 2003	Group 2613

US PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	APPLICANT	English Abstract	English Trans.	FILING DATE
SS	JP 2618042	06/11/97	Matsushita Elect.	х		06/15/89
SS	WO 2004/ 086070 Al	10/07/04	Semiconductor Energy Lab Co. Ltd	х		03/17/04

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

(Include name of author (in CAPITAL LETTERS), title of article or item (book, magazine, journal, serial, symposium, catalog, etc.) date, pages(s), volume-issue number(s), publisher, city and/or country where published).

EXAMINER: /Stephen Sherman/ (07/11/2006) DATE CONSIDERED: 07/11/2006

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LIST OF PUBLICATIONS CITED BY APPLICANT

<u>Atty Docket No.</u> 0553-0387	<u>Serial No.</u> 10/733,103	
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U.S. PATENT DOCUMENTS

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*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
II :		DATE 10/04/88 11/26/91 04/25/95 10/20/98 11/15/01 09/19/02 09/19/02 06/03/03 03/23/04 07/13/04 07/13/04 12/02/04 02/01/05 02/17/05 09/29/05	Aoki et al Gascoyne Ishizuka Hashimoto Koyama Hiroki Hiroki et al Gardner Pereira et al Iwase et al Koyama Koyama Hiroki Tanada Hiroki	CLASS 358 307 324 326 345 324 438 327 365 326 345 345 327 327 257		
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FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	APPLICANT	English Abstract	English Trans.	FILING DATE
SS SS	JP 05-256914 JP 2618042	10/08/93 03/11/97	Toshiba Corp. Matsushita Elect. Corp.	x x		03/12/92 06/15/89
SS	JP 2000- 047255	02/18/00		X		07/27/98
SS	JP 2002- 032035	01/31/02	Semiconductor Energy Lab Co. Ltd	Х		05/10/01
SS	JP 2002- 350513	12/04/02	Semiconductor Energy Lab Co. Ltd	х		03/12/02
SS	JP 2003- 031814	01/31/03	Semiconductor Energy Lab Co. Ltd	X	!	03/19/02
ss	WO 2004/ 086070 Al	07/10/04	Semiconductor Energy Lab Co. Ltd	Х		03/17/04

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	U.S. PATENT DOCUMENTS								
	*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE		
	FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	DATE	APPLICANT	English Abstract	English Trans.	FILING DATE		
·	SS	JP 2002- 116423	04/19/02	Sharp Corp.	Х.		10/10/00		

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

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			<u>Atty Docket No.</u> 0553-0387		<u>Serial No.</u> Not Assigned					
LIST OF PUBLICATIONS CITED BY APPLICANT			<u>Applicant</u> Takeshi OSADA et al							
			<u>Filing Date</u> Herewith	<u>Group</u>		·				
		v.s	. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE				
SS	US 2001- 0035526 A1	11/01/01	Yamazaki et al	257	57	04/24/01				
		FORE	IGN PATENT DOCUMENT	es						
	DOCUMENT NUMBER	DATE	NAME	English Abstract	English Trans.	FILING DATE				
SS	JP 2002- 014337	01/18/02	Semiconductor Energy Lab Co. Ltd	x d		04/26/01				
(Include name symposium, ca	of author (in CAP	ITAL LETTERS)	NCN PATENT LITERATE, title of article or it olume-issue number(s), published).	em (book, magazi	ne, journal,	serial, atry where				
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